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Dated:November 3, 2005

nature:

Docket No.: 08228/019001

(PATENT)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Patent Application of:

Shiro Sakai et al.

Application No.: 10/044,686

Art Unit: 1722

Filed: January 11, 2002

Examiner: Matthew J. Song

For: NITRIDE SEMICONDUCTOR CHIP AND

METHOD FOR MANUFACTURING NITRIDE

SEMICONDUCTOR CHIP

REPLY UNDER 37 C.F.R. 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated September 9, 2005, please reconsider this application in view of the following.